



國立交通大學

National Chiao Tung University

有機電子元件實驗室

ORGANIC ELECTRONICS LAB.

Organic light-emitting diodes

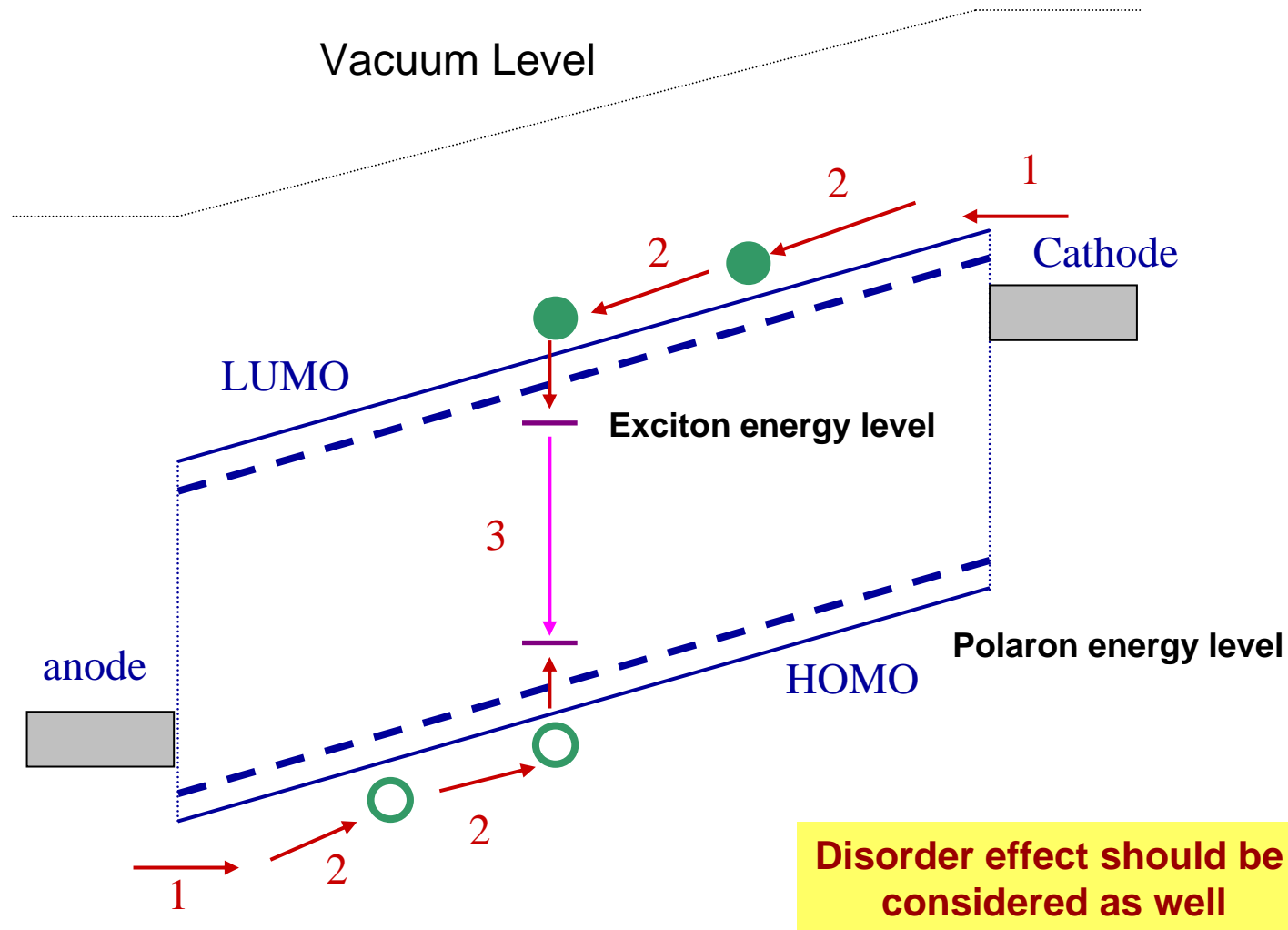
Charge injection and transport

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National Chiao Tung University

Closer look at the electric processes in OLEDs



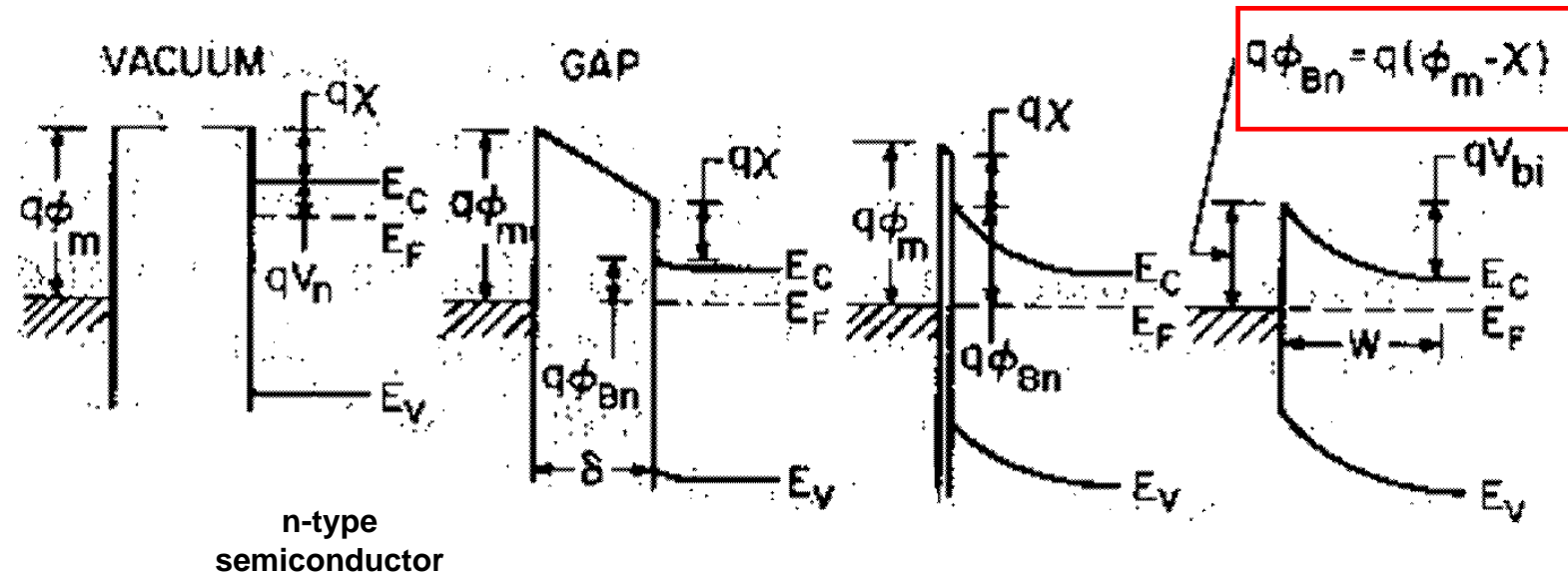
Ohmic Contact

A metal-semiconductor contact that has negligible contact resistance relative to the bulk or spreading resistance of the semiconductor

A satisfactory ohmic contact should not significantly perturb device performance

The ohmic contact has no rectification

Metal-Semiconductor Contact

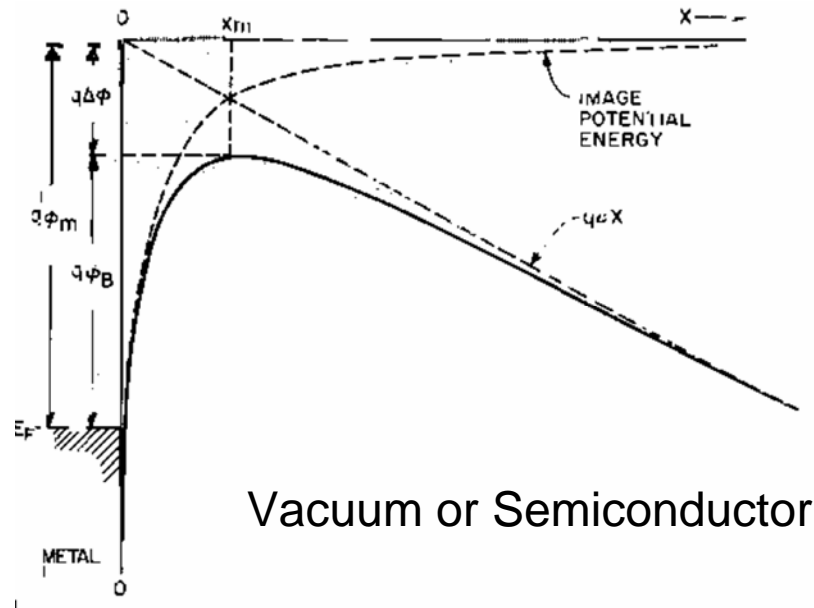


Work function: $q\Phi_m$ (metal) $q(\chi+V_n)$ (semiconductor)
 V_n : the energy different between E_C and E_F

$$\text{Depletion depth : } W = \left(\frac{2\epsilon_S(V_{bi}+V_R)}{eN_d} \right)^{1/2}$$

Schottky Effect

The image-force-induced lowering of the potential energy for charge carrier emission when an electric field is applied



$$\Delta\Phi = \left(\frac{eE}{4\pi\epsilon_s} \right)^{1/2}$$

The current transport process

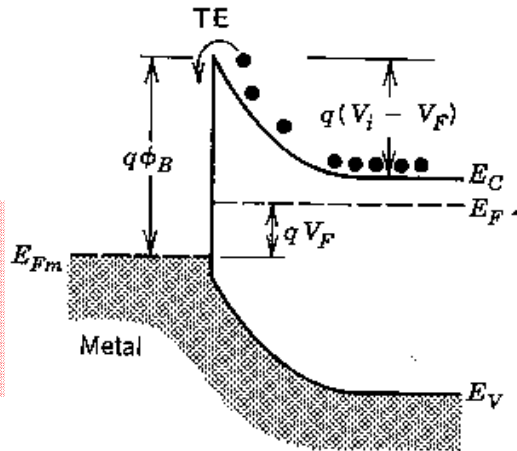
Thermionic Emission is the dominant mechanism

$$j_{RS} = A^* T^2 \exp \left(- \frac{\Phi_B - \beta_{RS} \sqrt{F}}{k_B T} \right)$$

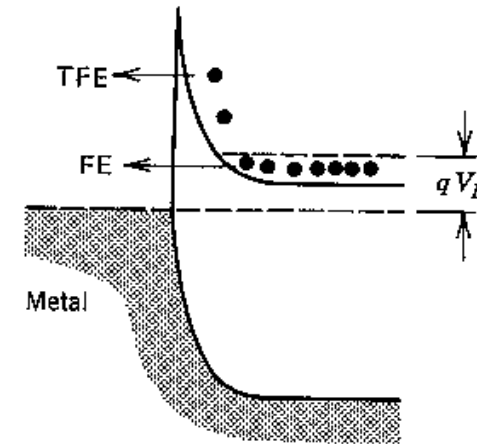
Richardson constant $A^* = 4\pi q m^* k_B^2 / h^3$

$$\beta_{RS} = \sqrt{q^3 / 4\pi \epsilon \epsilon_0}$$

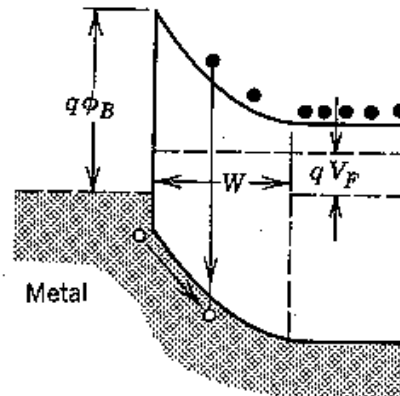
zero-field injection barrier Φ_B



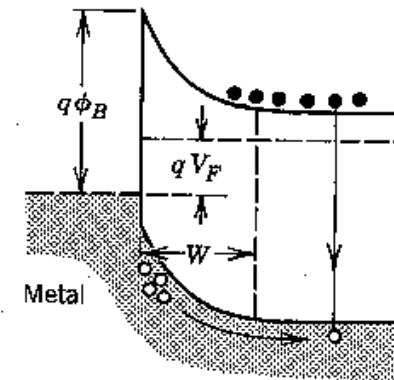
thermionic emission



tunneling



electron-hole
pair recombination



minority carrier injection

Organic/Metal interface

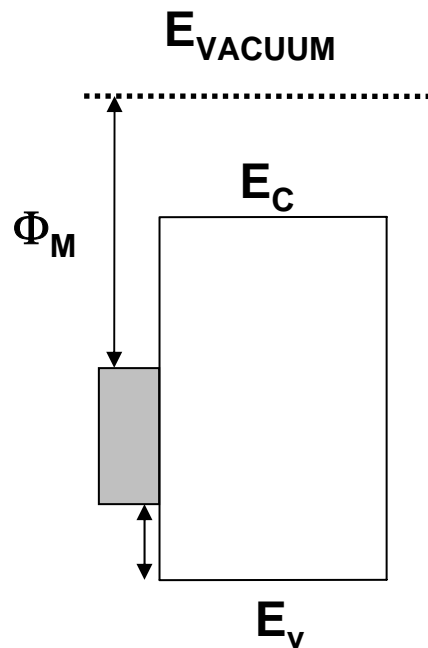
First approximation :

A “clean” organic and metal interface

In the absent of doping, interface dipoles and other effect,

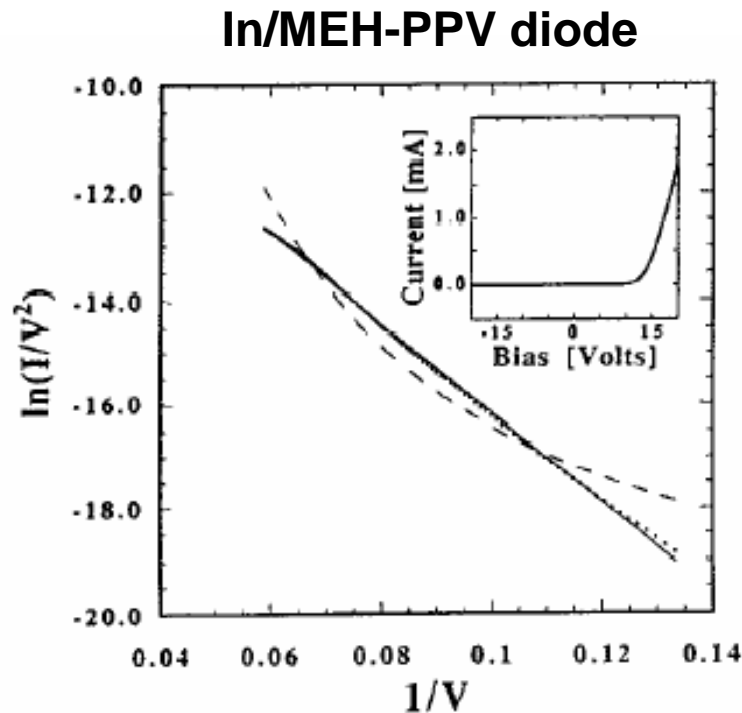
The depletion depth (W) is much large than the layer thickness (t)

$$W \gg t$$



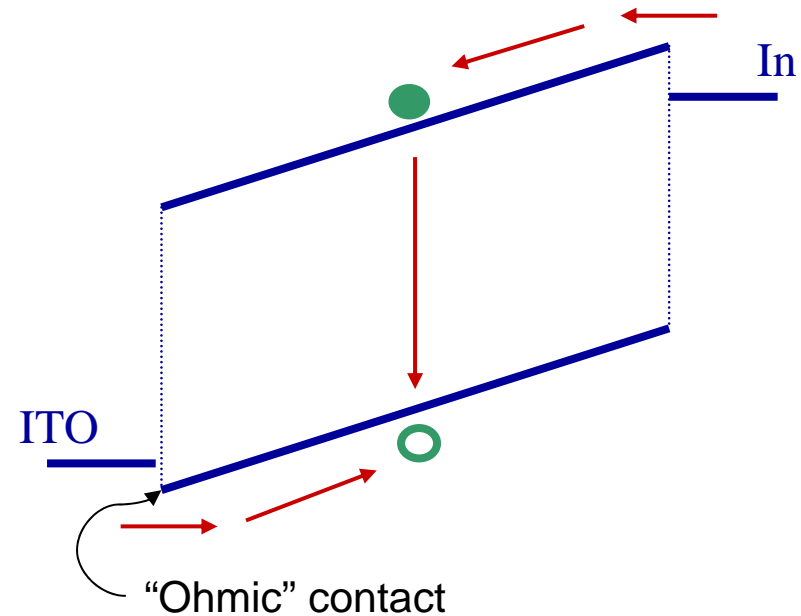
$$\text{Depletion depth : } W = \left(\frac{2\epsilon_S(V_{bi} + V_R)}{eN_d} \right)^{1/2}$$

Thermionic emission vs Tunneling



Dashed line : thermionic emission
Solid line: tunneling

Oversimplified!!



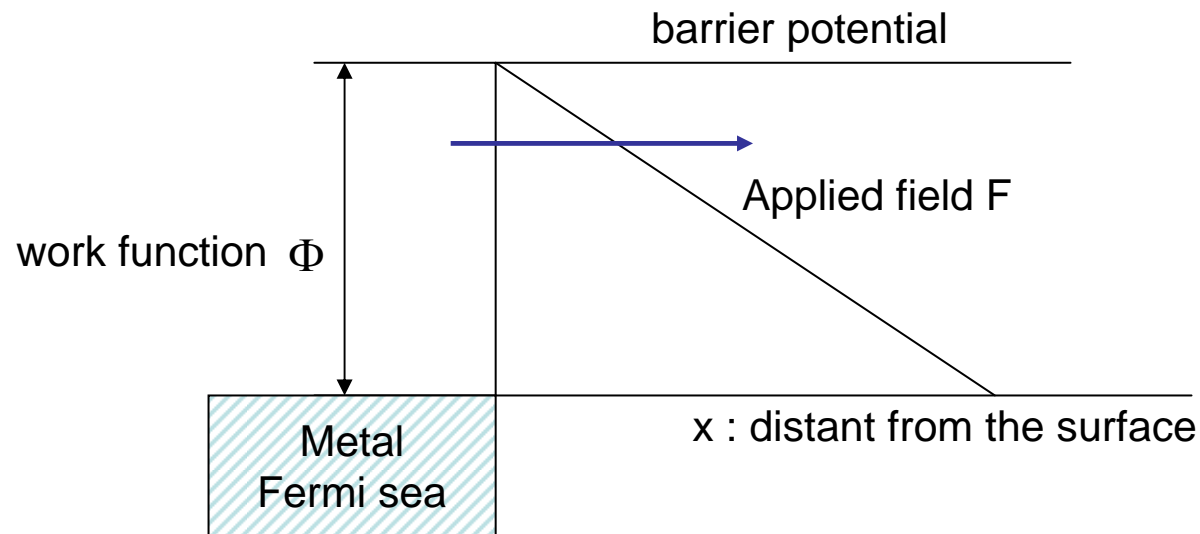
Field dependence:

Thermionic emission: $I \propto \exp(-eV/nKT)$

Tunneling: $I \propto V^2 \exp(-b/V)$

Tunneling

Quantum mechanism were first applied to the field emission of electrons from a metal by **Fowler & Nordheim**

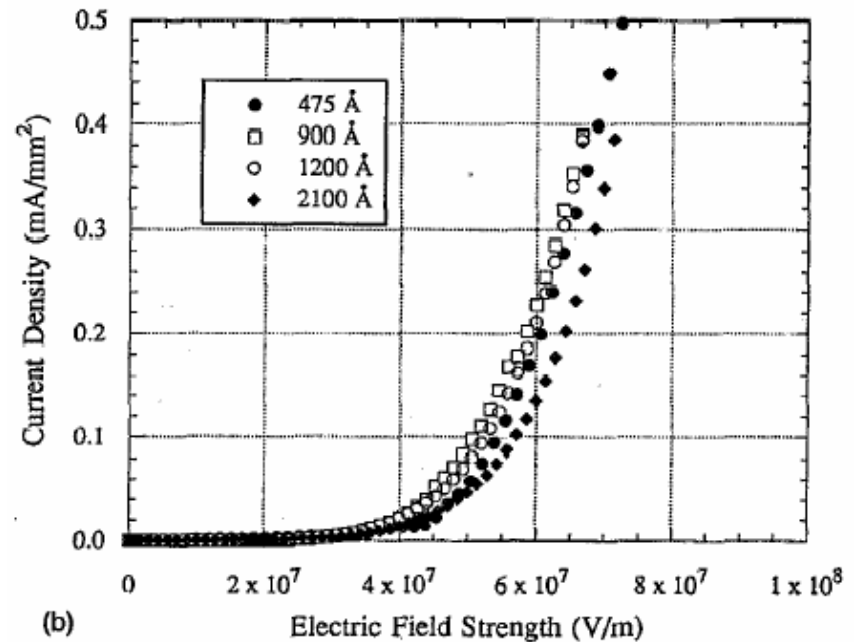
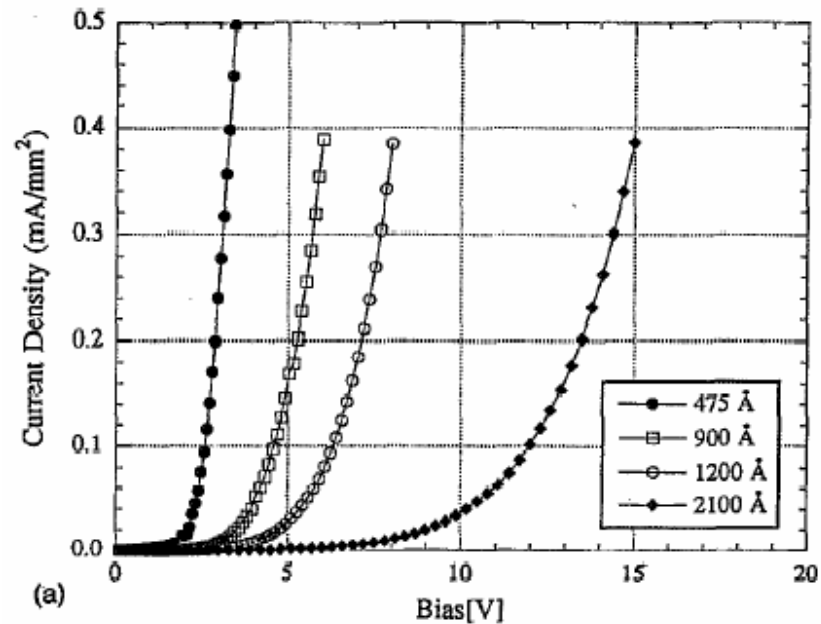


$$j_{\text{FN}} = \frac{A^* q^2 F^2}{\Phi_B \alpha^2 k_B^2} \exp \left(- \frac{2\alpha \Phi_B^{3/2}}{3qF} \right)$$

$$\text{with } \alpha = \frac{4\pi\sqrt{2m^*}}{h}.$$

Thickness dependence of I-V characteristics

ITO/MEH-PPV/Ca

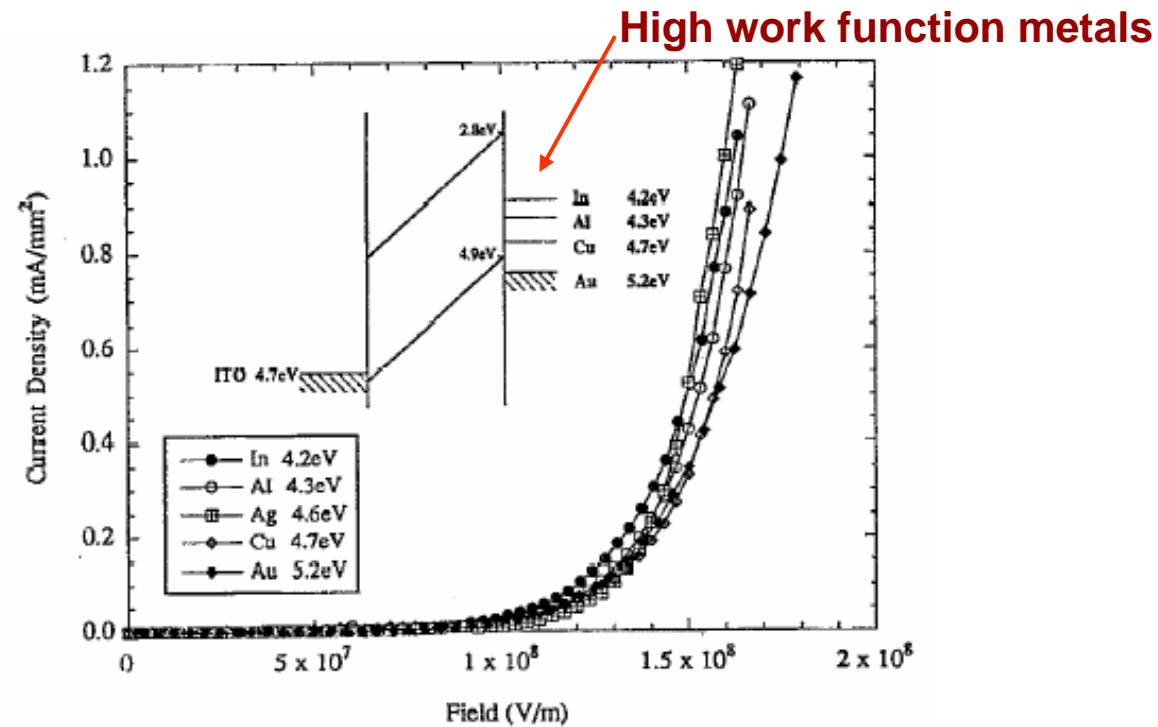


I-V characteristics depend, not on the voltage, but on the electric field

I. D. Parker JAP 75, 1656 (1994)

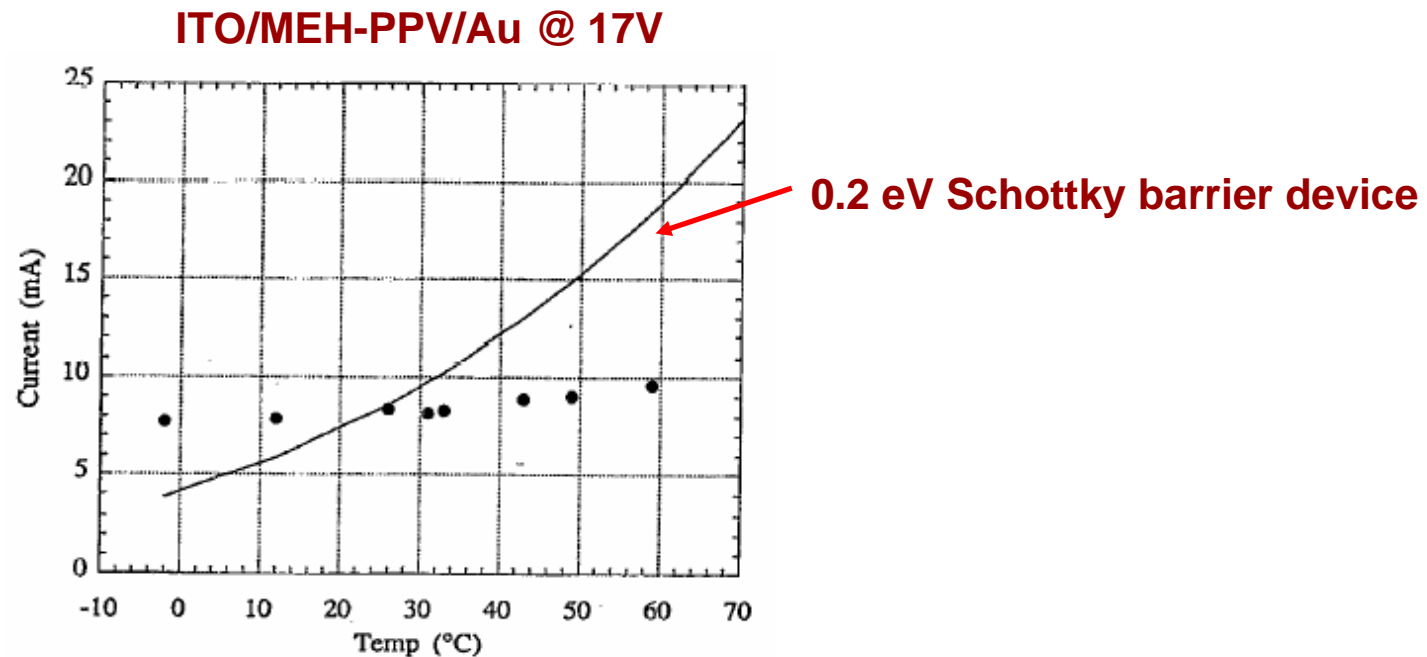
The very first systematic study of the charge injection

“Hole-only” device



The current is controlled by the hole injection

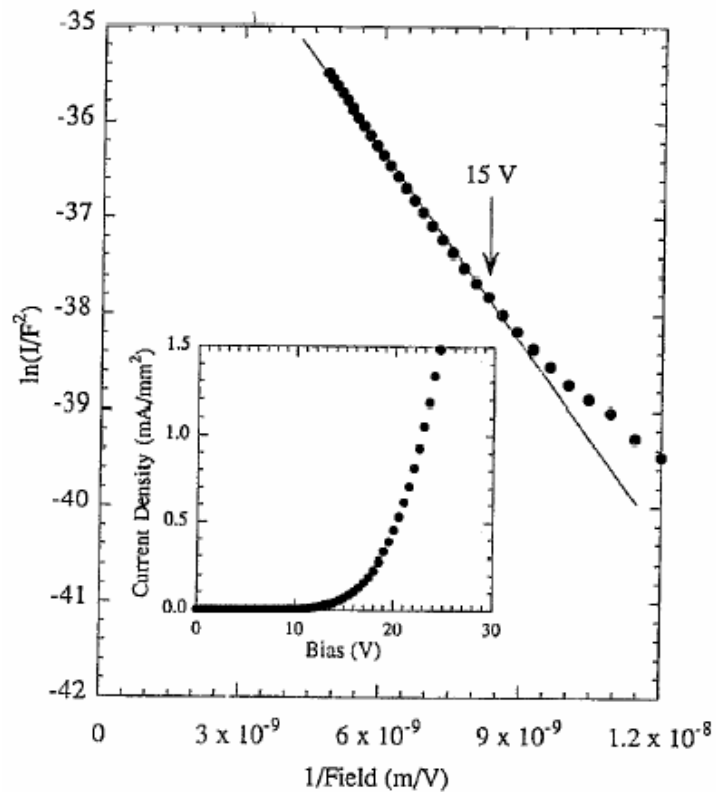
Temperature dependence of the I-V characteristics



The injection current is not likely due to thermionic emission

Fowler-Nordheim Plot

ITO/MEH-PPV/Au



$$I \propto F^2 \exp\left(\frac{-\kappa}{F}\right)$$

$$\kappa = \frac{8\pi \sqrt{2m^*} \varphi^{3/2}}{3qh} \quad \text{for a triangular barrier}$$

φ : the barrier height

m^* : the effective mass

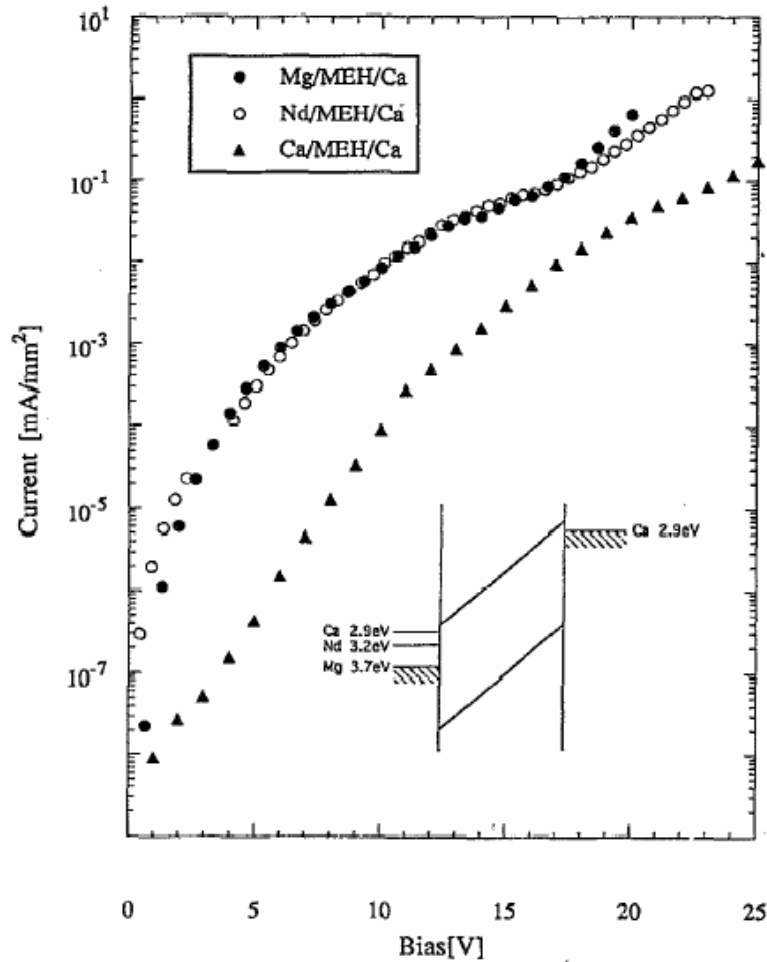
TABLE II. The barrier height inferred from the Fowler-Nordheim analysis for a range of "hole-only" devices.

Device structure	Barrier height (eV)
ITO/MEH-PPV/In	0.21–0.23
ITO/MEH-PPV/Ag	0.28–0.33
ITO/MEH-PPV/Al	0.22–0.24
ITO/MEH-PPV/Cu	0.22–0.26
ITO/MEH-PPV/Au	0.19–0.22

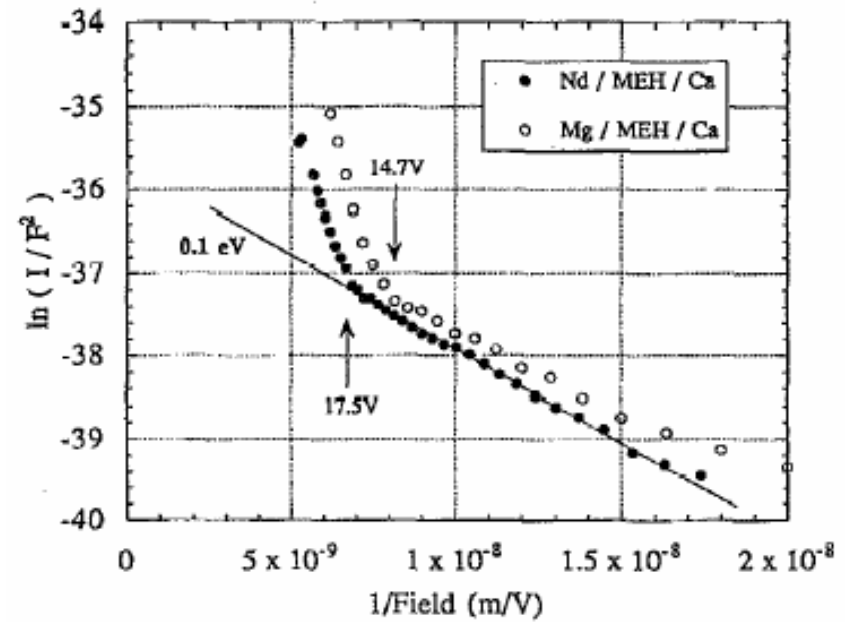
constant barrier height ~ 0.2-0.3 eV

I. D. Parker JAP 75, 1656 (1994)

“Electron-only” device



Fowler-Nordheim Plot



I. D. Parker JAP 75, 1656 (1994)

Device efficiency vs cathode work function

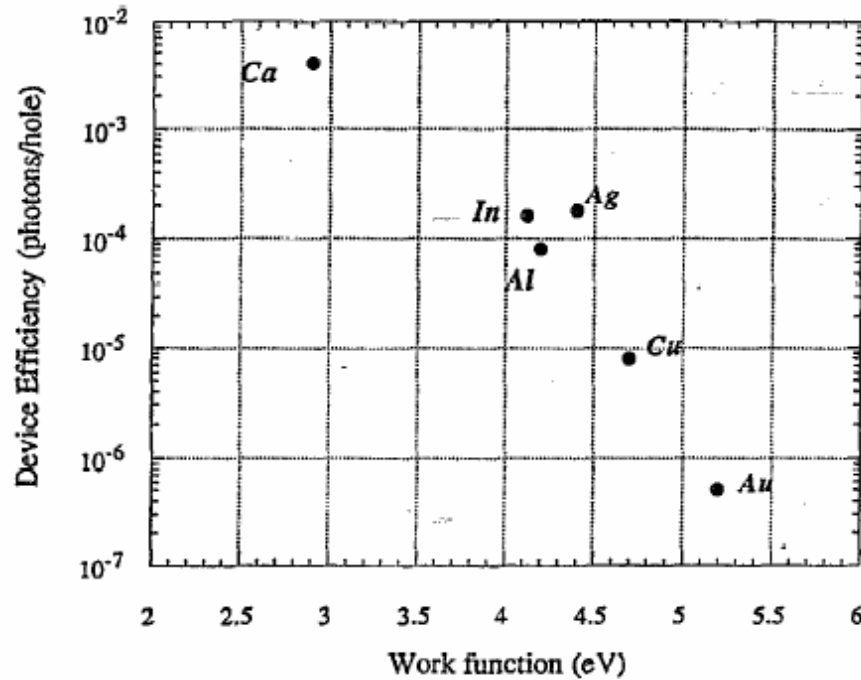
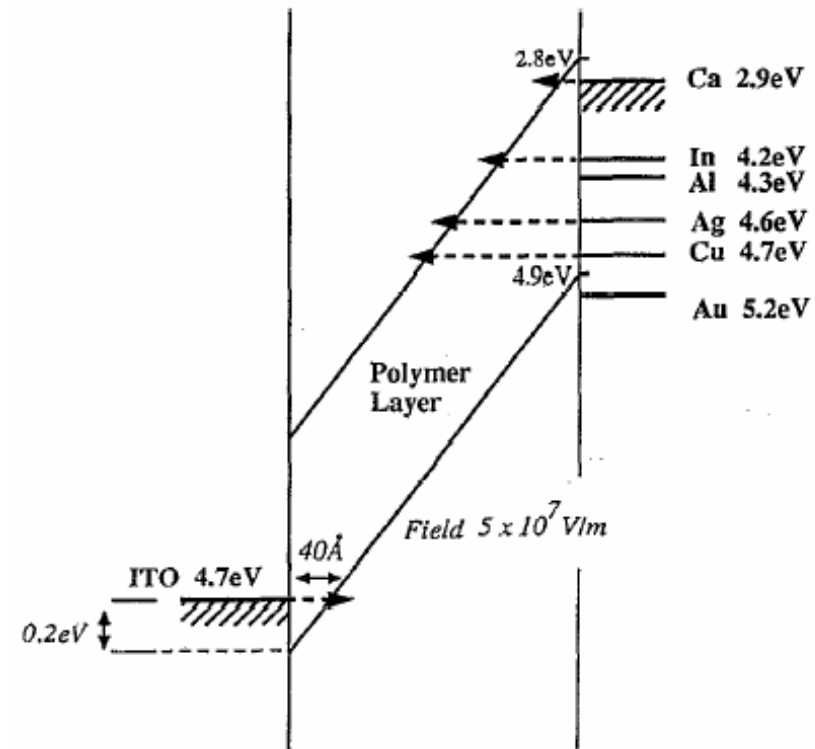


TABLE I. External quantum efficiency for ITO/MEH-PPV LEDs with various cathode materials.

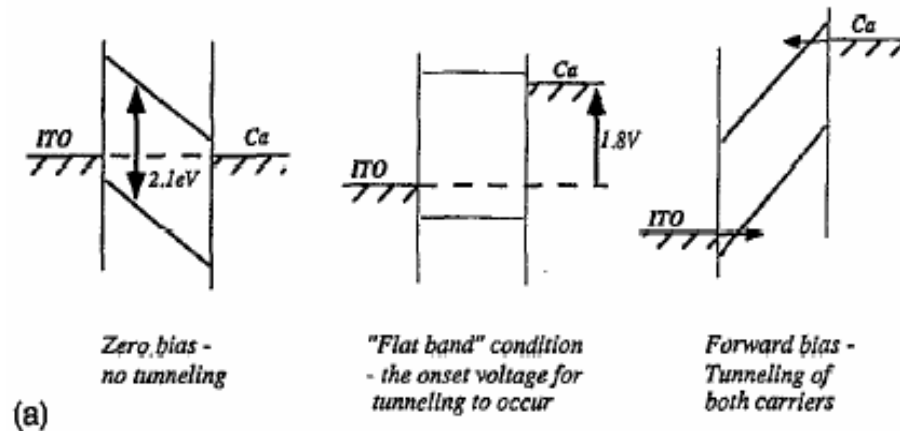
Metal	Work function (eV) ^a	Band offset (eV)	Efficiency (photons/hole)
Ca	2.87-3.00	~0.1	4×10^{-3}
In	4.12-4.20	1.3-1.4	1.6×10^{-4}
Ag	4.26-4.74	1.5-1.9	1.8×10^{-4}
Al	4.06-4.41	1.2-1.6	8×10^{-5}
Cu	4.65-4.70	1.9	8×10^{-6}
Au	5.1-5.47	2.3-2.7	5×10^{-7}

The band diagram of the model

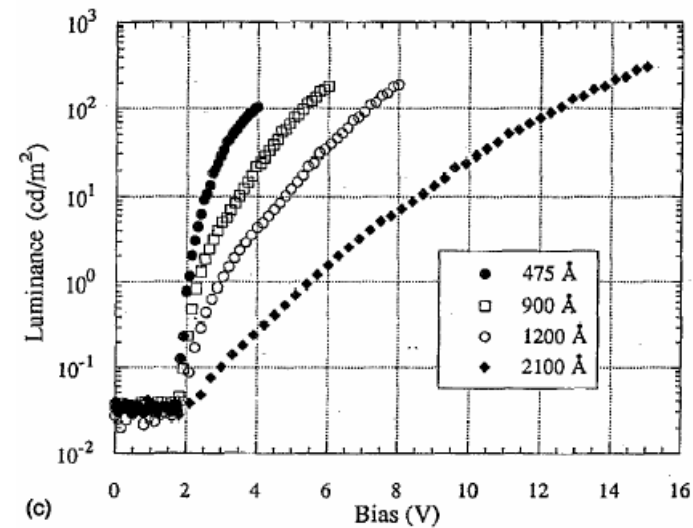
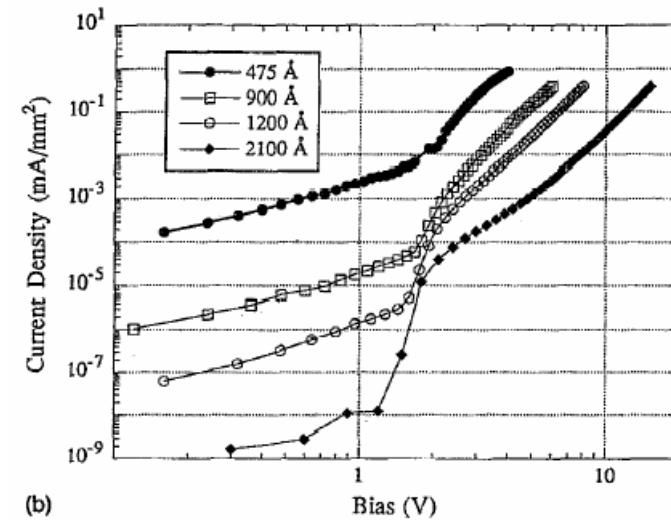


in forward bias

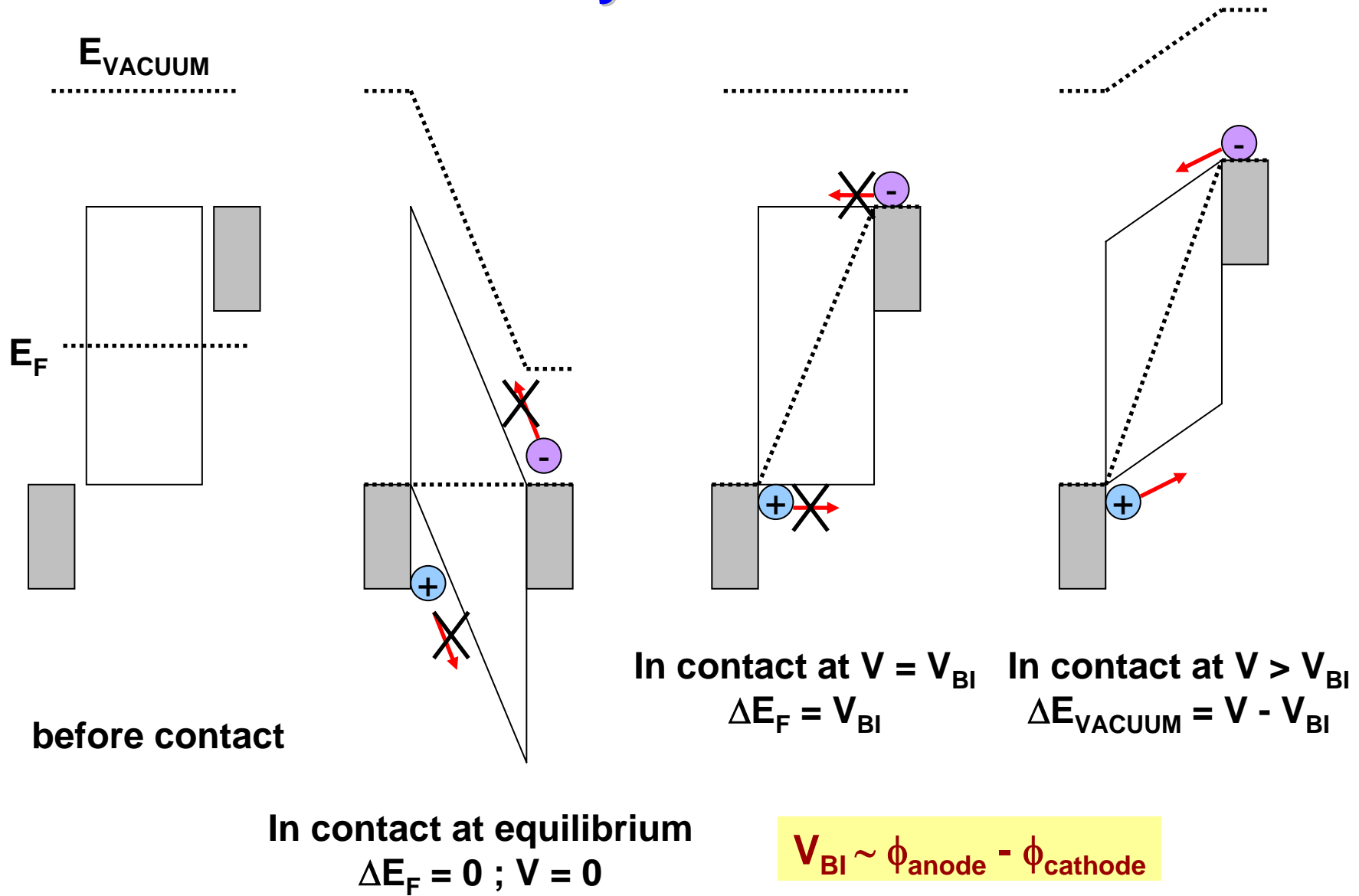
The band diagram of the model



The rigid band model seems appropriate, since little band bending occurs.
The device immediate depletion due to low carrier concentration ($<10^{14} \text{ cm}^3$)

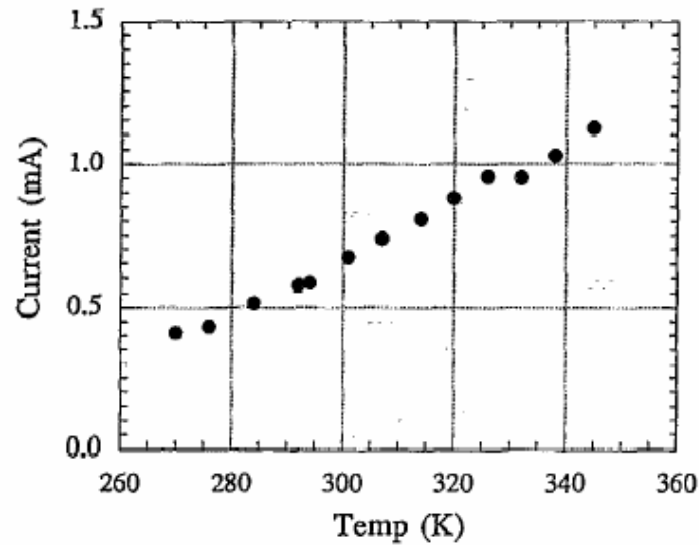


Summary of J-V curve



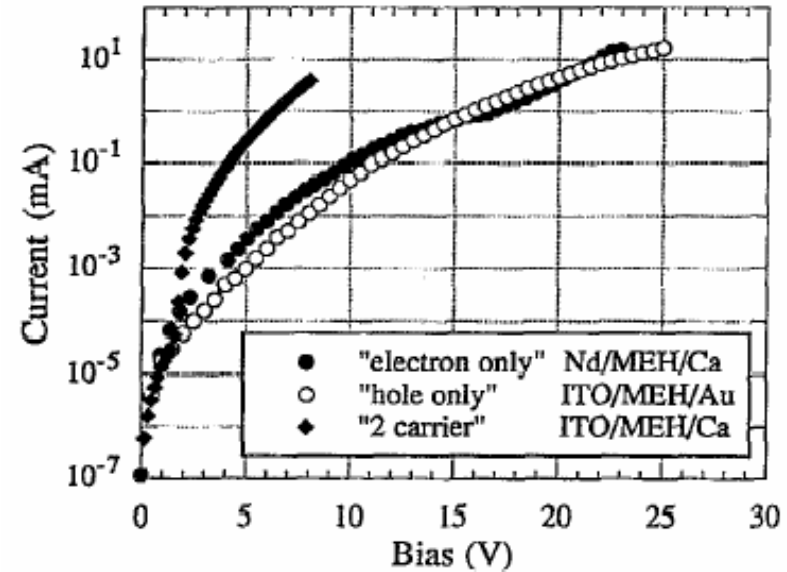
Limits the model

ITO/MEH-PPV/Ca



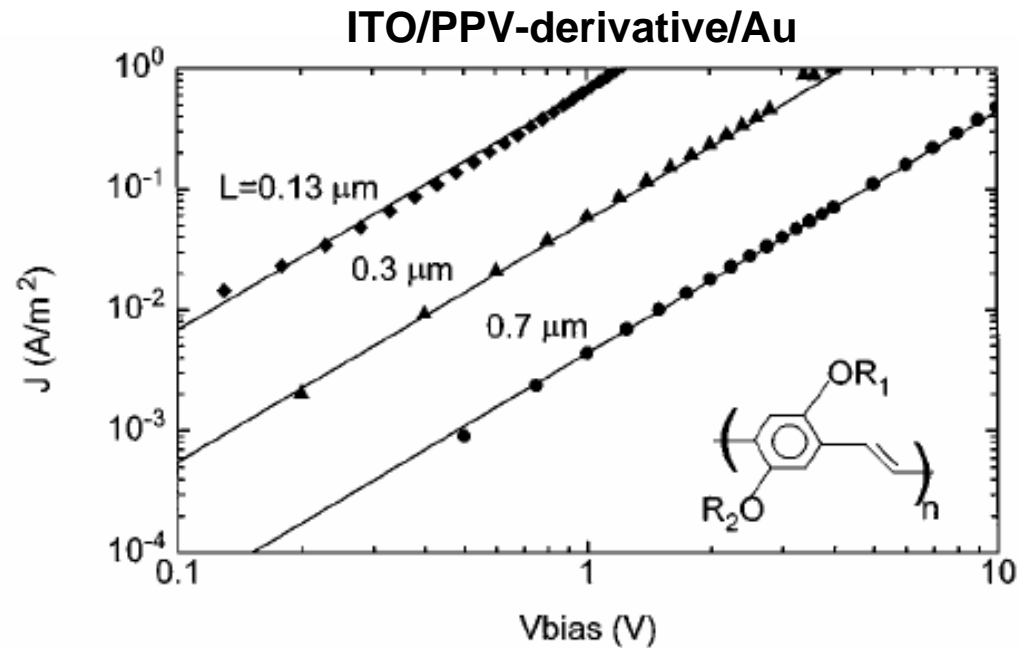
weak temp. dependence injection current
due to the low injection barrier height

The barrier height for
electron injection $\sim 0.1\text{eV}$ ($4kT$)



space-charge limiting effect

An alternative model

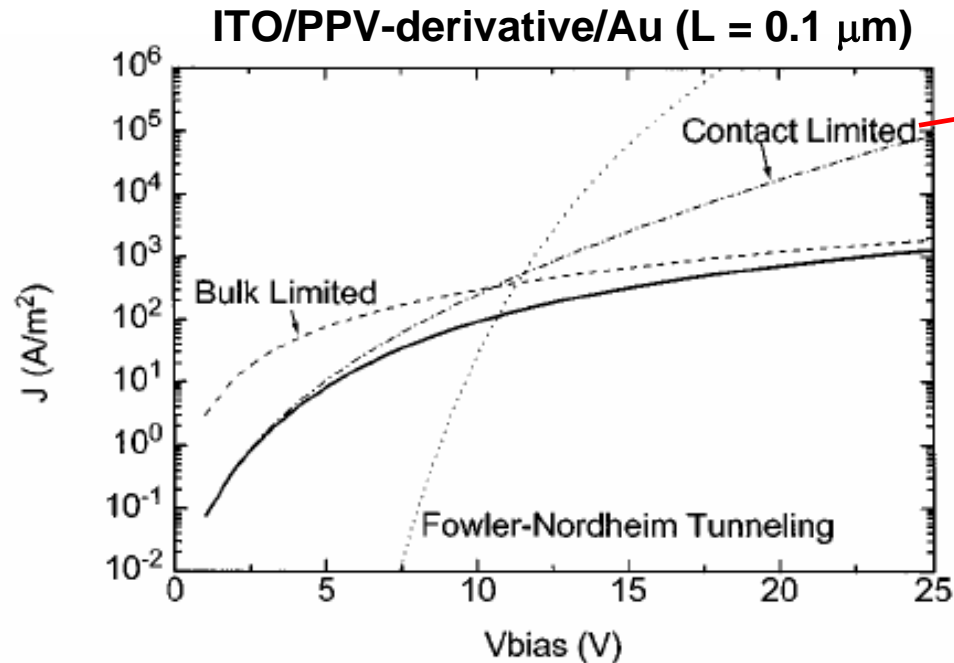


The I-V characteristics follows SCLC : $J = \frac{9}{8} \epsilon_0 \epsilon_r \mu_p \frac{V^2}{L^3}$

$$\mu = 5 \times 10^{-7} \text{ cm}^2/\text{V.s}$$

P. W. Blom, *et al.* Appl. Phys. Lett. 68, 3308 (1996)

An alternative model



Thermionic emission-diffusion theory :

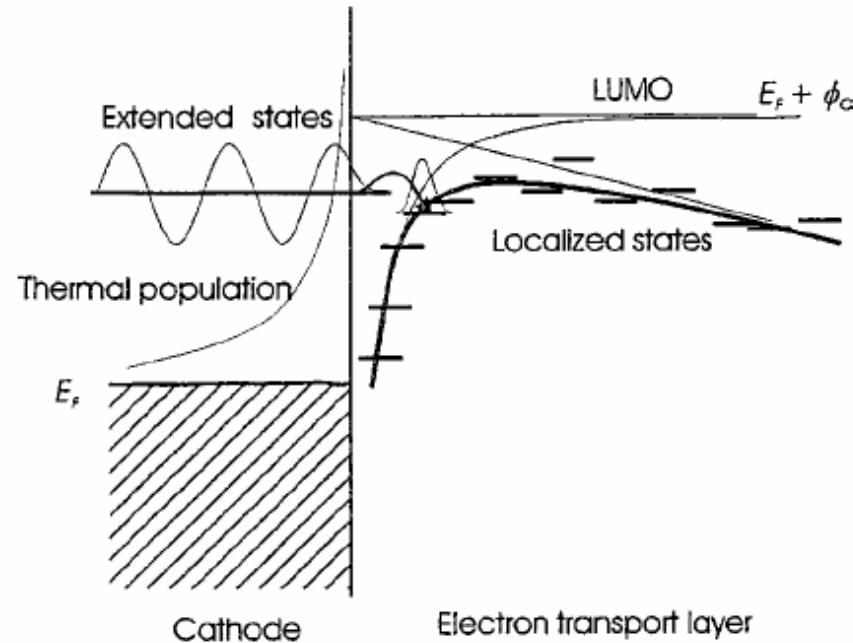
$$J = q N_c \mu F(0) \exp\left(-\frac{q \phi_b}{kT}\right)$$

$F(0)$ the electric field at the contact

**At low bias, diffusion-limited injection;
At high bias, space-charge effects dominate.**

**In general, it depends on both ϕ_{b0} and L whether
the conduction is injection or space-limited
SCLC is usually observed if $\phi_{b0} < 0.2$ V**

Energetics of the charge injection process



The barrier height

The image potential

The potential due to the interfacial electric field

A random component due to disorder

(the mean free path is of order of molecular distance)

Two extreme types of carrier motion in solids

Highly delocalized plane wave in a broad carrier band

e.g. Ge, bandwidth (W) ~ 3 eV,

scattering time $\tau \sim m\mu/e \sim 10^{-3}$ sec

mean free path ~ 100 nm \gg atomic separation (0.25nm)

$\mu \gg 1$ cm²V⁻¹sec⁻¹

$\mu \propto T^{-n}$ (n>1)

Localized charges moving by hopping

bandwidth (W) $\leq kT$

being scattering virtually at every step

$\mu \ll 1$ cm²V⁻¹sec⁻¹

$\mu \propto \exp(-E/kT)$ (E : activation energy)

Molecular crystals : falls in an intermediate category

$\mu \sim 1$ cm²V⁻¹sec⁻¹

Transport mechanisms in solids

Main difference:

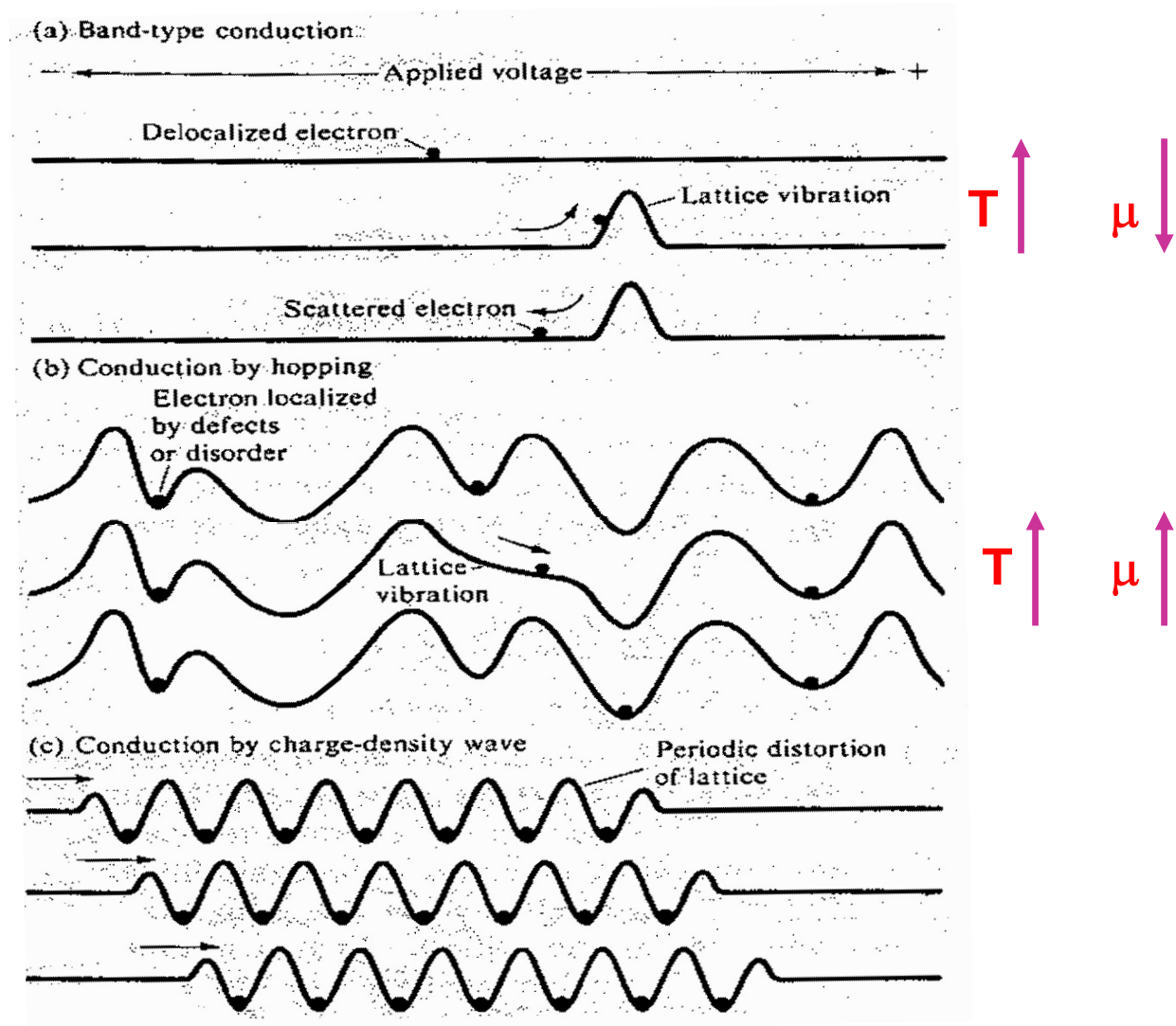
Phonon scattering limited

$$\mu = a T^{-n}$$

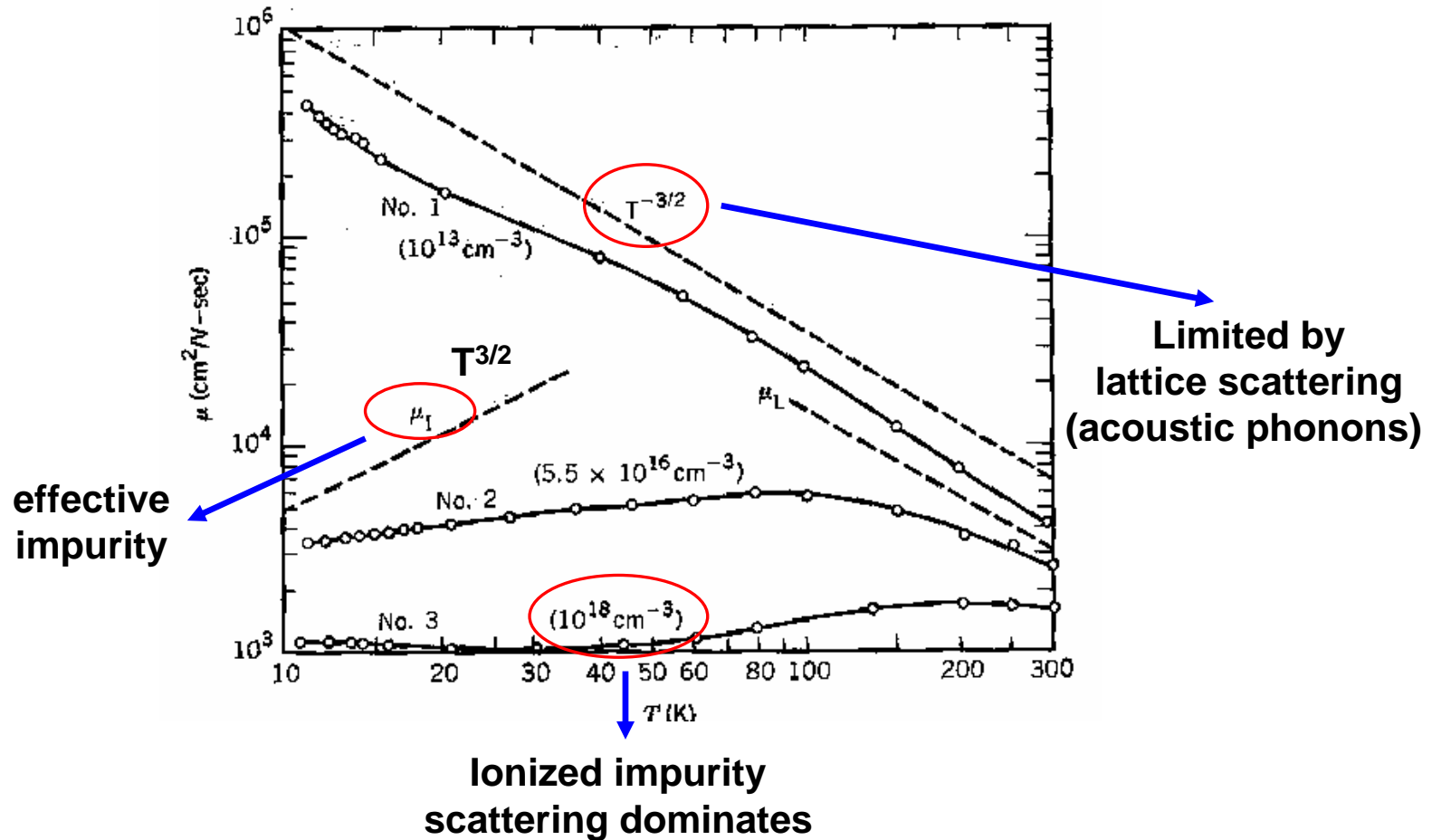
$$(n \sim 1)$$

Phonon assisted

$$\mu = \mu_0 \exp -(E_a/kT)$$



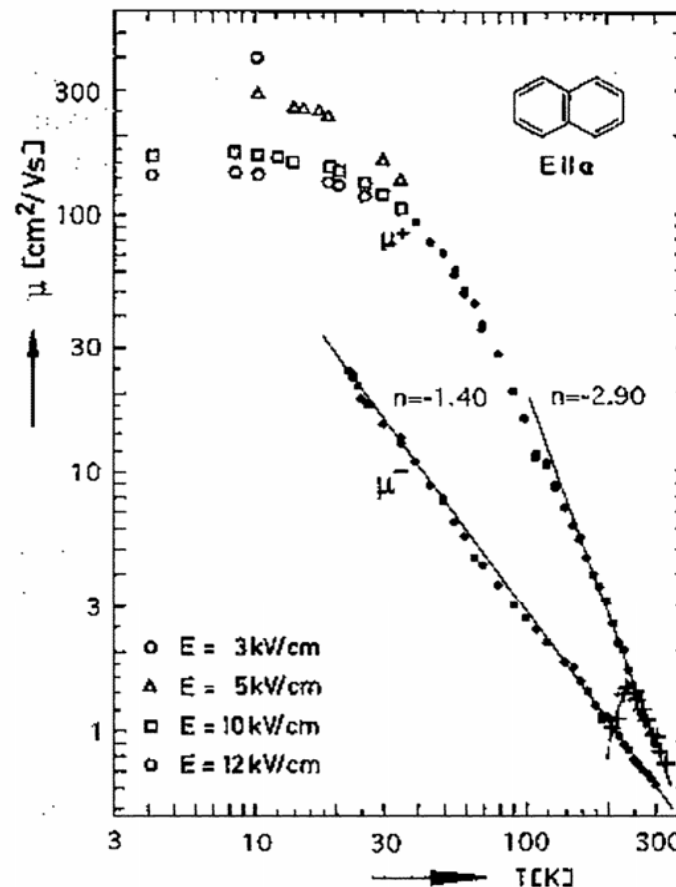
Electron mobility in n-type Ge at different temp. For various doping levels



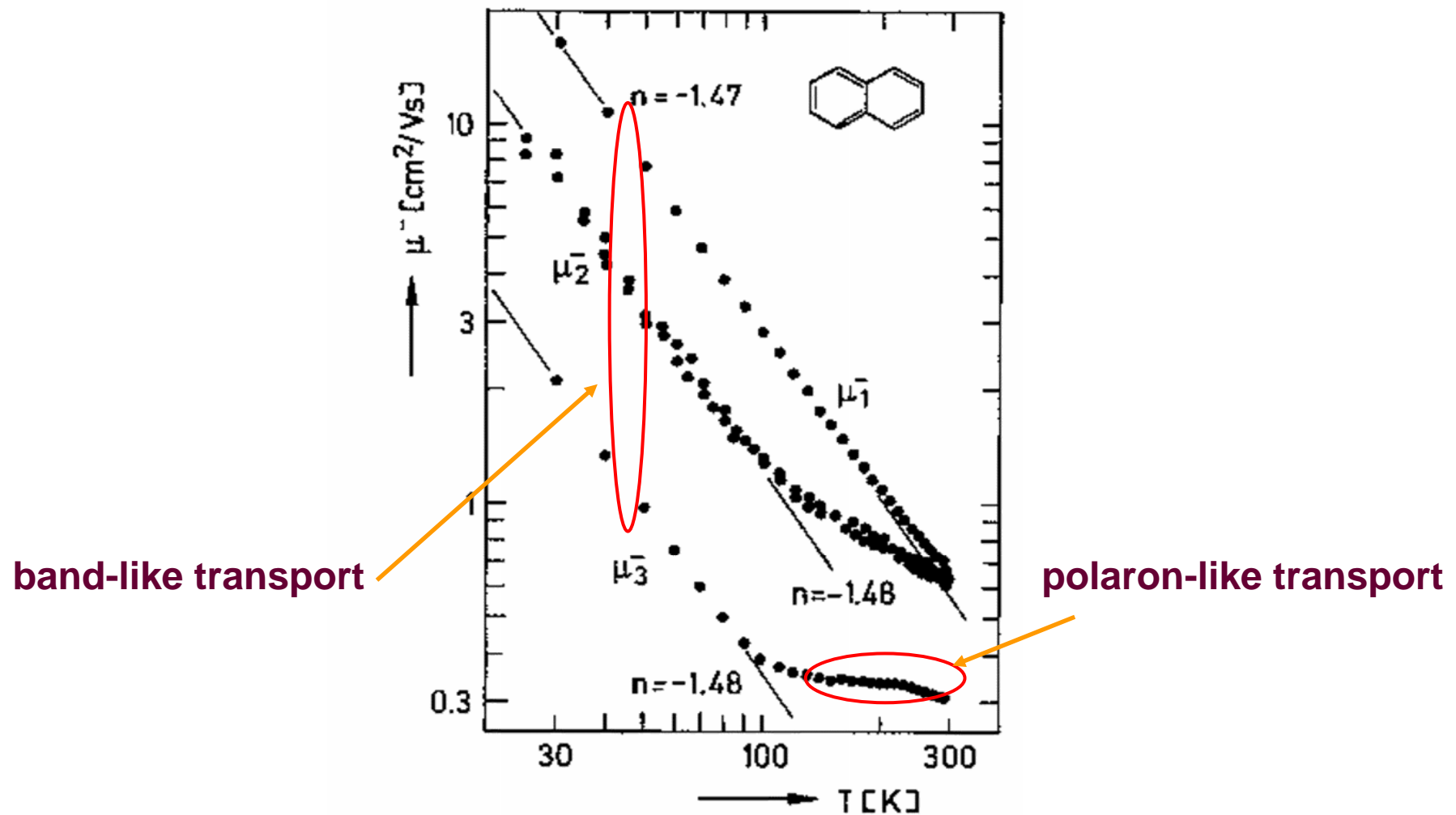
Ultrahigh pure single crystal of polyenes

At low temperature, coherent bandlike transport become the prevalent Transport mechanism.

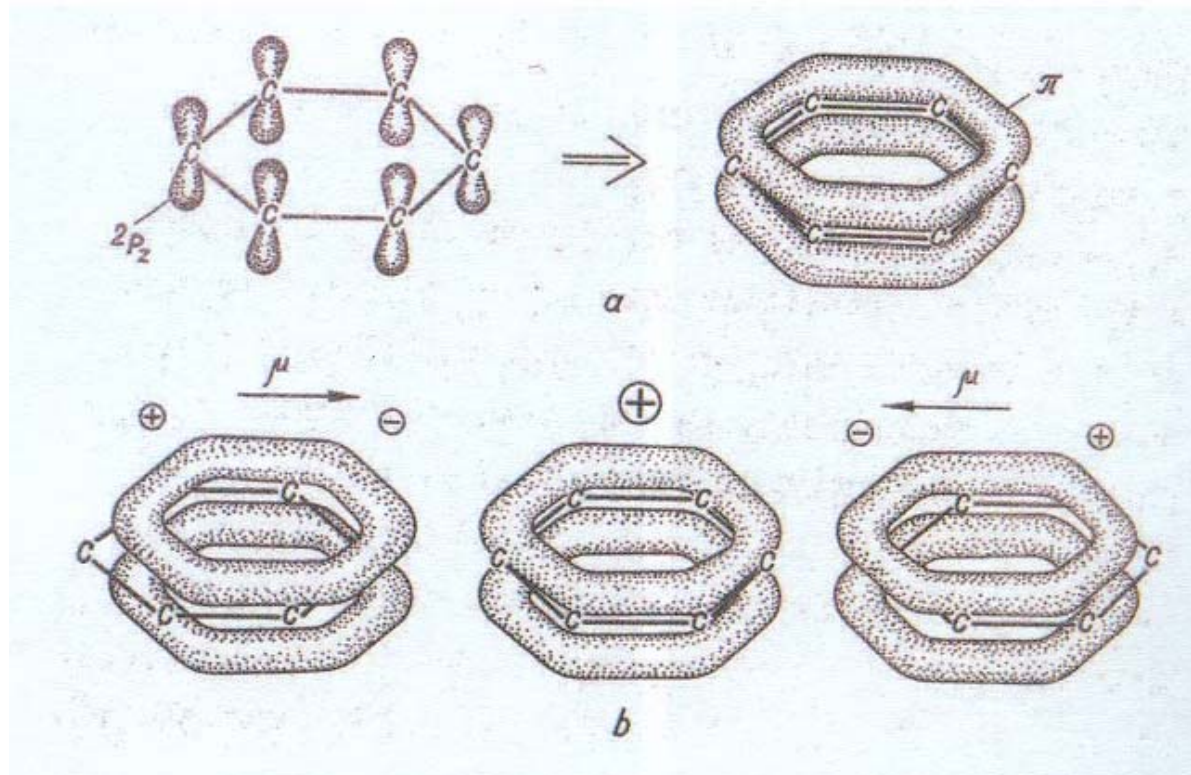
e.g. $\sim 400 \text{ cm}^2\text{V}^{-1}\text{sec}^{-1}$ (hole) in single crystal naphthalene at 4K



Anisotropic electron mobilities of organic crystals



Strong electronic polarization



formation of induced dipoles μ on neutral molecules of the crystal
in the field of a localized positive charge carrier

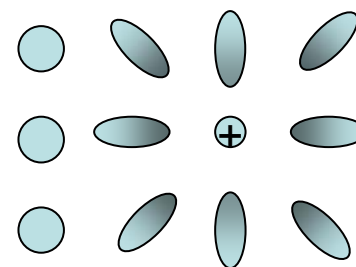
Polarons

Strong-phonon-electron coupling → a localized polaron

π orbitals of organics has high polarizability

The typical charge-carrier localization time is several order of magnitude greater than the relaxation time for electronic polarization of the surrounding lattice molecules

The charge move together with their electronic polarization “cloud”



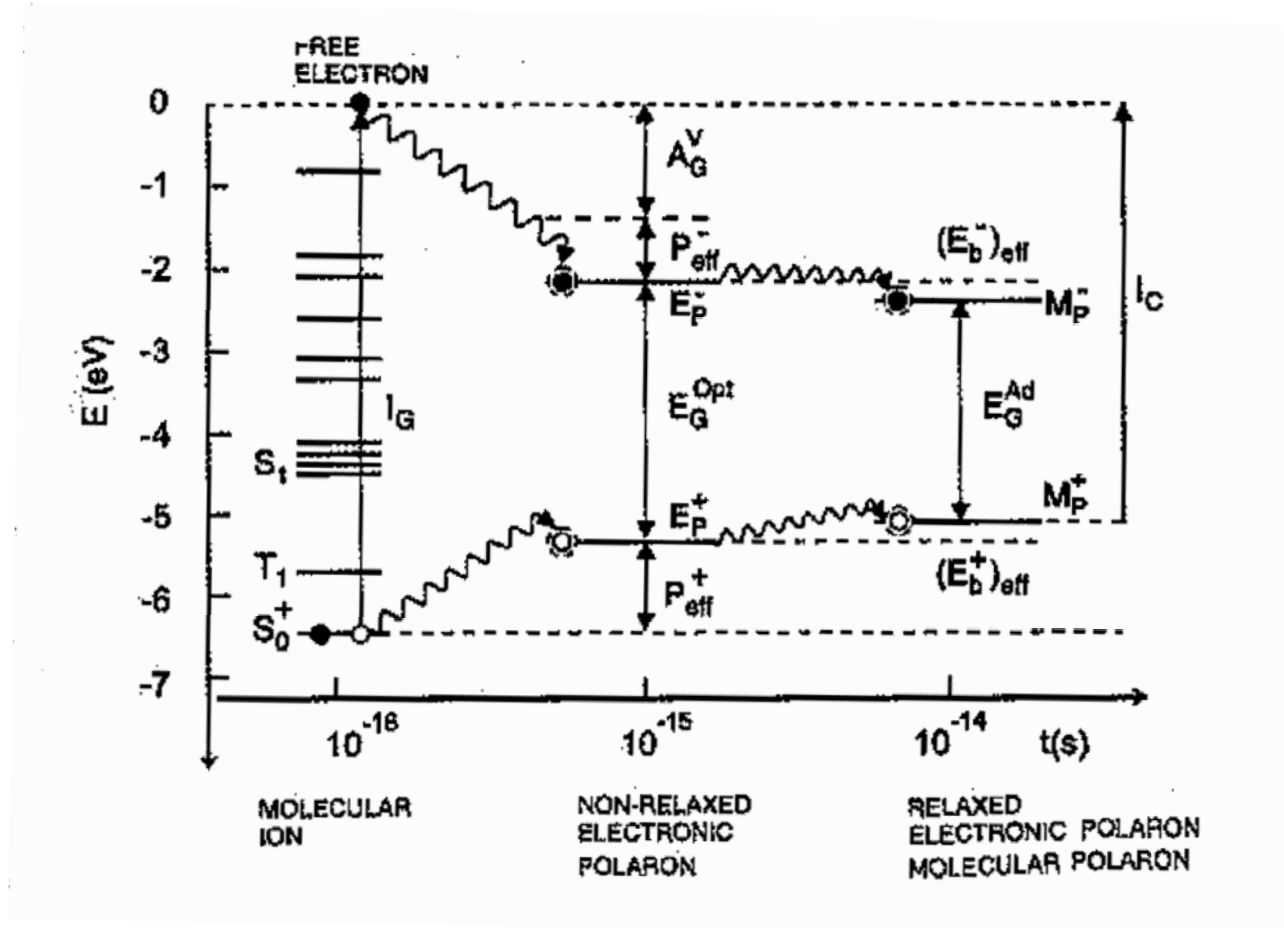
The quasifree charge carriers are called Polarons

The charge carrier motion should be described in the framework of a hopping model (self-trapped in the polarization well)

Ways to create Polarons:

Charge injection, chemical doping, thermal excitation, and optical excitation

Electronic Polarons vs Molecular Polarons



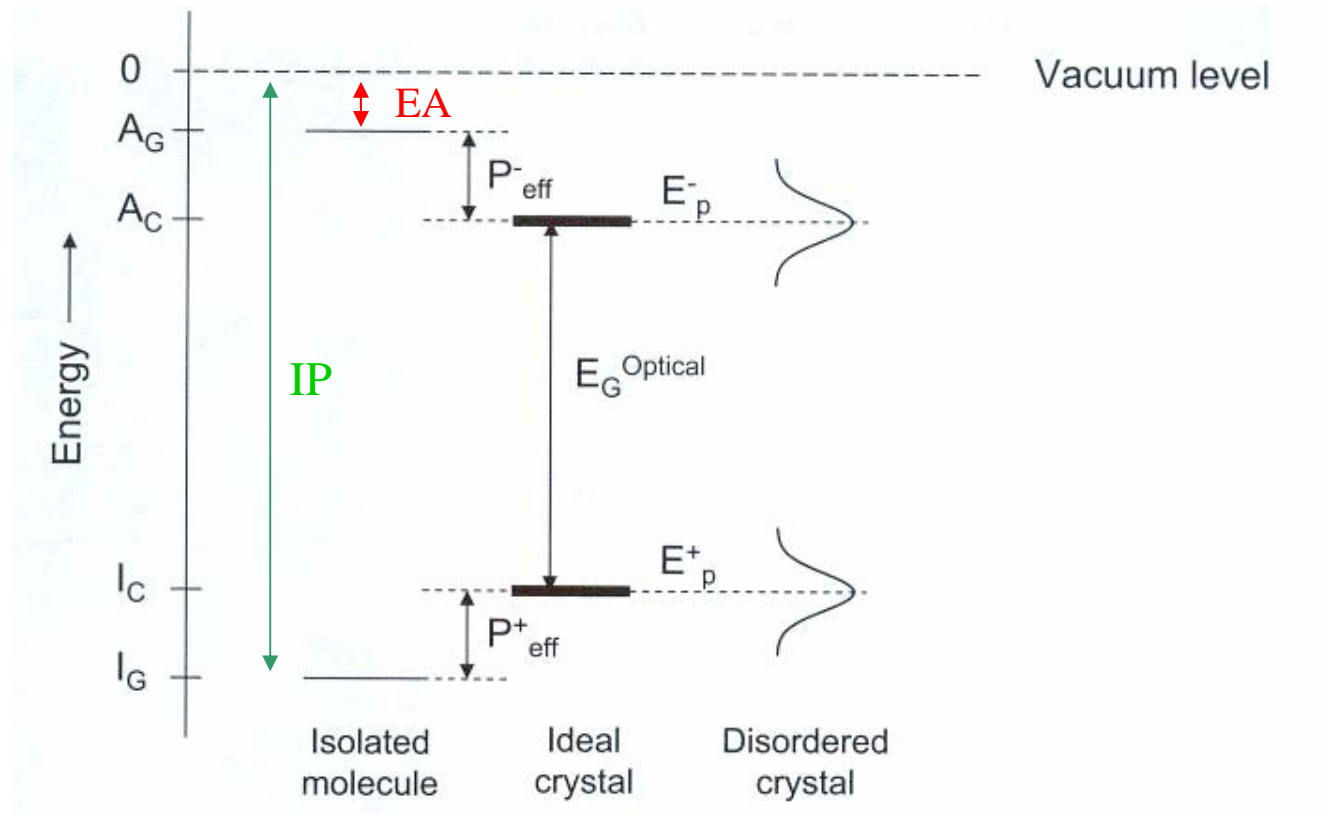
E_p^- & E_p^+ : **non-relaxed electronic polaron** states

P_{eff}^- & P_{eff}^+ : effective electronic polarization energies

M_p^- & M_p^+ : **molecular polaron** conductivity levels

$(E^-)_{eff}$ & $(E^+)_{eff}$: effective formation energies of a molecular polaron
(due to vibronic polarization)

Energy Bands in Organic Molecular Crystals



I_c : molecular crystal ionization potential

A_c : molecular crystal electron affinity

E_p^- & E_p^+ : electronic polaron energy level

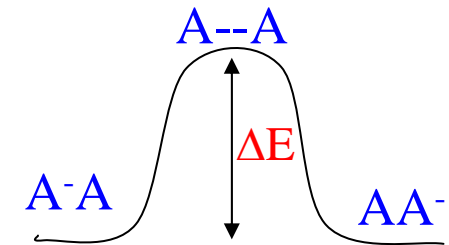
P_{eff}^- & P_{eff}^+ : effective electronic polarization energies

Hopping mechanism of charge transport

For polaron-type transport,

$$\sigma = \sigma_0 \exp(-\Delta E/2kT)$$

ΔE : the activation energy



(no energy exchange)

Phono-activated hopping mechanism



k_{ET} : rate-constant of electron transfer
depends on the electronic overlaps of the pair of molecules

$$\mu = \mu_0 \exp(-\Delta E/kT)$$

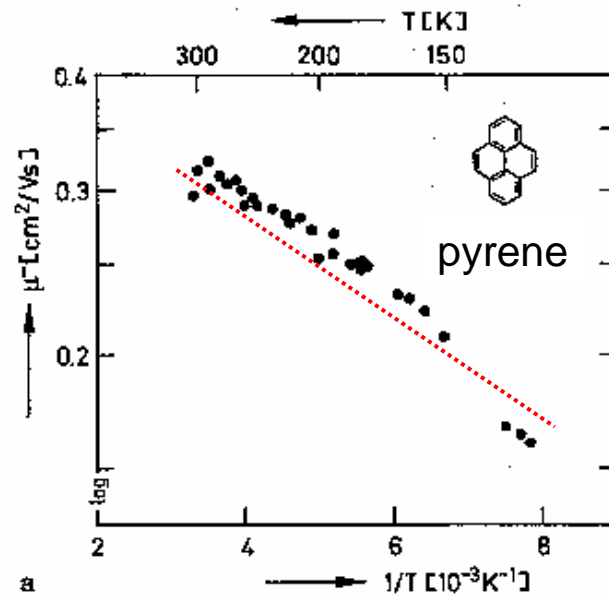
ΔE : the activation energy



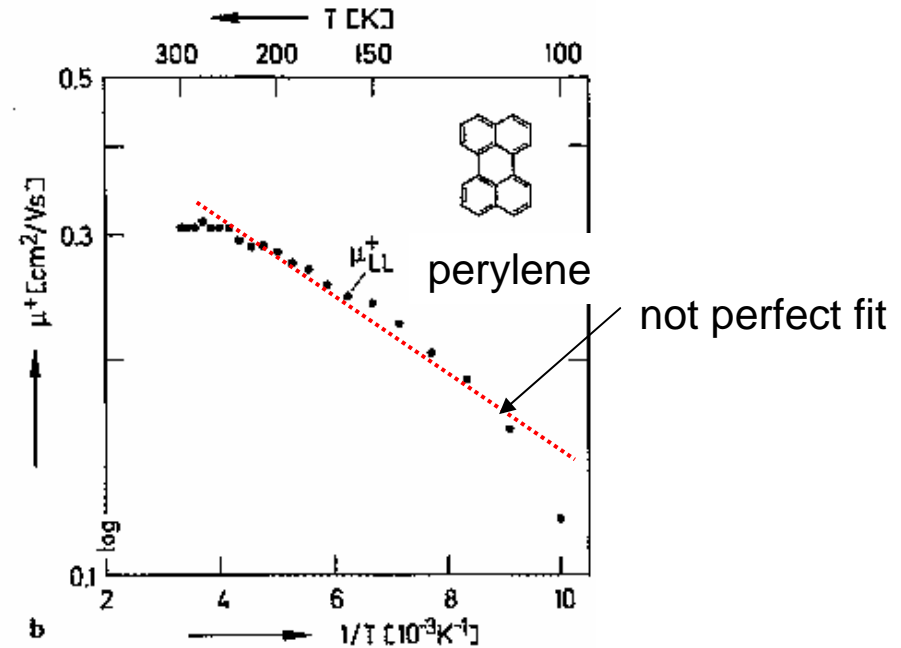
$$\log(\mu) = \frac{-\Delta E}{k} - \frac{1}{T}$$

Arrhenius plot of the mobilities of organic materials

electron mobility



hole mobility



$$\log(\mu) = \frac{-\Delta E}{k} \frac{1}{T}$$

Some highly purified organic materials
are based on polaron hopping

Two general types of organic materials

Two general cases

“Low” mobility materials

transport via hopping

typical mobility $10^{-6} \sim 10^{-1} \text{ cm}^2\text{V}^{-1}\text{sec}^{-1}$

common for polymeric or disorder organic semiconductors

“high” mobility materials

transport via narrow band transport

typical mobility $10^{-1} \sim 10 \text{ cm}^2\text{V}^{-1}\text{sec}^{-1}$

$\mu(T)$ depends on details (traps, doping, bandwidth, etc.)

common for small molecular crystal organic semiconductors